

Docket No.: 106570-2
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Anthony Polak et al.

Application No.: 09/832,663

Confirmation No.: 1850

Filed: April 11, 2001

Art Unit: 1641

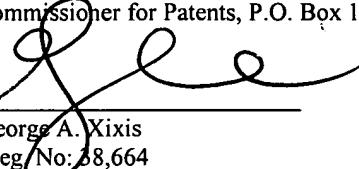
For: Sensor Device And Methods For Manufacture

Examiner: Yang, Nelson C

Certificate of Mailing (37 C.F.R. 1.8(a))

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November 18, 2005
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By: 
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AMENDMENT RESPONSE

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Introductory Comments

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this document.